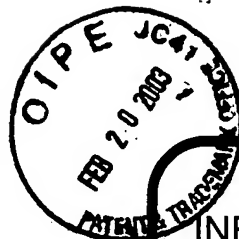


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Sheet 1 of 2

Application Number	To be assigned 10/065362
Filing Date	Herewith 10-9-02
Applicants	Kotwicki, Lippa, Björnsson, Smith, Meyer, Russell, Visser, Parsons, Husak
Group Art Unit	
Examiner Name	
Attorney Docket Number	202-1295

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

EXAMINER INITIAL*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
H H H		"Viscosity sensing using a Love-wave device", Jakoby et al., Elsevier Science S.A., Sensors and Actuators A 68 (1998), pp. 275-281.	
		"A Love wave sensor for (bio)chemical sensing in liquids", Kovacs et al., Sensors and Actuators A, 43 (1994), pp. 38-43.	
		"The Emergence of Physical Chemosensors and Biosensors", Vellekoop, Proc. Of Transducers '01, Munich, Germany, June 2001.	
		"Determination of Viscosity Changes of Cement Paste with a Smart Lamb-Wave Sensor System", Van Beek et al., Proc. Of the 2 nd RILEM Workshop on Hydration and Setting, Dijon, France, June 1997, pp. 329-338.	
		"Microfabrication of acoustic-wave devices", Vellekoop, Proc. of SPIE vol. 3224, Micromachined Devices and Components III, Austin, Texas, September 1997, pp. 90-97	
		"Design of a Smart Microacoustic Liquid Sensor System, Part I: Microacoustic Device", "Sensor Technology in the Netherlands: State of the Art", van den Bert et al., ISBN0-7923-5010-3, 1998, pp. 165-170.	
		"Design of a Smart Microacoustic Liquid Sensor System, Part II: Electronics", "Sensor Technology in the Netherlands: State of the Art", van den Bert et al., ISBN0-7923-5010-3, 1998, pp. 171-177.	
		"Properties of Love waves: applications in sensors", Jakoby et al., Special issue on SAW devices and their applications, Journal of Smart Materials and Structures, vol. 6, no. 6, December 1997, pp. 668-679.	
H H H		"Acoustic wave sensors and their technology", Vellekoop, Ultrasonics, vol. 36, 1998, pp. 7-14.	

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HAI HUYNH

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3/19/04

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Sheet 2 of 2

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Application Number	To be assigned 10/065, 362
Filing Date	Herewith 10-9-02
Applicants	Kotwicki, Lippa, Bj msson, Smith, Meyer, Russell, Visser, Parsons, Husak
Group Art Unit	
Examiner Name	
Attorney Docket Number	202-1295

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HHH		"Substrates for Zero Temperature Coefficient Love Wave Sensors", Jakoby et al., IEEE Transactions on UFFC, vol. 47, no. 3, May 2000, pp. 701-705.	
I		"Analysis of Viscous Losses in the Chemical Interface Layer of Love Wave Sensors", Jakoby et al., IEEE Transactions on UFFC, vol. 47, no. 3, May 2000, pp. 696-700.	
HHH		"Analysis and Optimization of Love Wave Liquid Sensors", Jakoby et al., IEEE Transactions on UFFC, vol. 45, no. 5, September 1998, pp. 1293-1302.	

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